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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kazuyoshi NAMBA

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For : SUBSTRATE CLEANING APPARATUS AND SUBSTRATE  
CLEANING METHOD

LETTER ACCOMPANYING APPLICATION

FILED UNDER 37 CFR 1.52(d)

Hon. Commissioner for Patents  
Washington, D.C. 20231

Sir:

The subject application is being filed in a foreign language (Japanese) under 37 C.F.R.

1.52(d). The enclosed Japanese language application includes 17 pages of written disclosure and 9 sheets of formal drawings.

This application is based on Japanese Patent Appln. No. 2000-259336 filed on August 29, 2000 and priority is claimed. Attached is a Claim For Foreign Priority and a certified copy of the foreign priority document.

A verified English language translation and signed Declaration will be filed in due course.

The filing fees with be paid in due course.

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1129 U.S. PRO

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11050 U.S. PRO  
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Respectfully submitted,

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